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Application/Control No.	Applicant(s)/Patent under Reexamination
10/537,544	NIESLONY ET AL.
Examiner	Art Unit

John Rivell

3753

SEARCHED				
Class	Subclass	Date	Examiner	
137	454.4 454.5 540 542 809 812	5/23/2007	0	
417	559 569	5/23/2007	\mathcal{C}_{j}	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST (US, USPGPubs, USOCR, EPO, JPO, Derwent, IBM Tech)	5/23/2007	R		
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